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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2812

Examiner: To be assigned

In Re PATENT APPLICATION Of:

Applicant(s) : LIANG et al.

Serial No. : 09/619,388

Filed : July 19, 2000

For : APPARATUS FOR
LOADING/UNLOADING WAFERS TO
AND FROM SEMICONDUCTOR
FABRICATION EQUIPMENT

Attorney Ref: LIE 105

STATUS REQUEST

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please let us know the status of the above-identified application and when an Action may be expected. Please respond via facsimile or e-mail Tonya Harris (Docketing Manager) at tonya@rabinchamp.com.

Respectfully submitted,

Steven M. Rabin

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August 28, 2003
Date

SMR:mrd

FEE ENCLOSED: \$
Please charge any further
fe to our Deposit Account
No. 18-0002